

Fig. 1

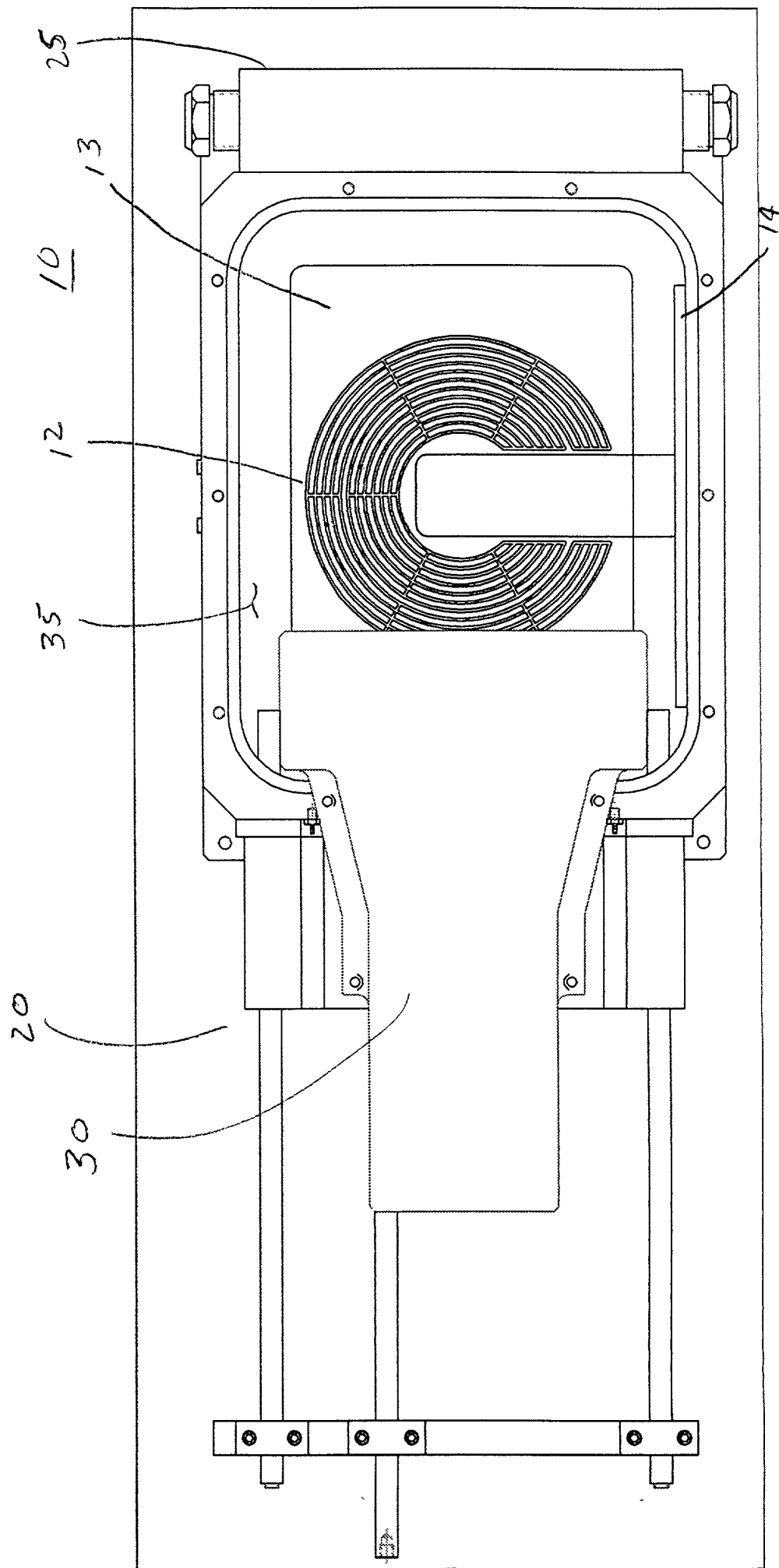


FIG. 2

10

30

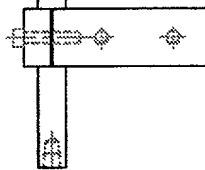
31 32

34

36

13

33 37



20

22

23

15 12

24

PROCESS GAS INJECTOR

PROCESS GAS COLLECTOR

UV BEAM

PROCESS GAS IN

WAFER

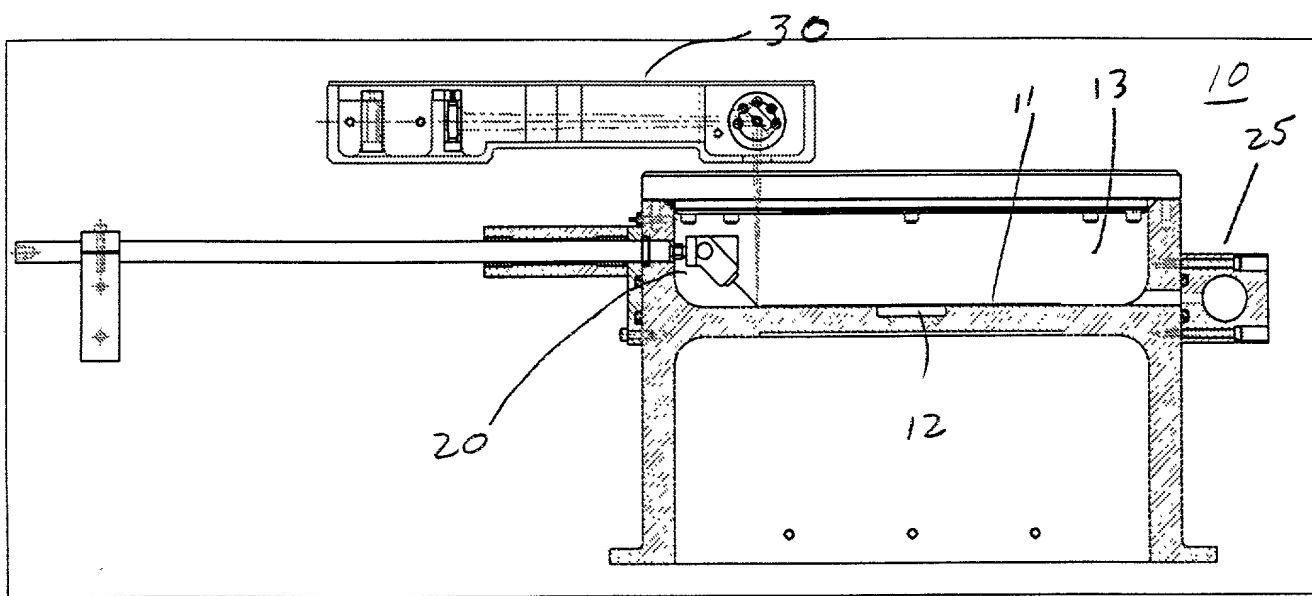


FIG. 3

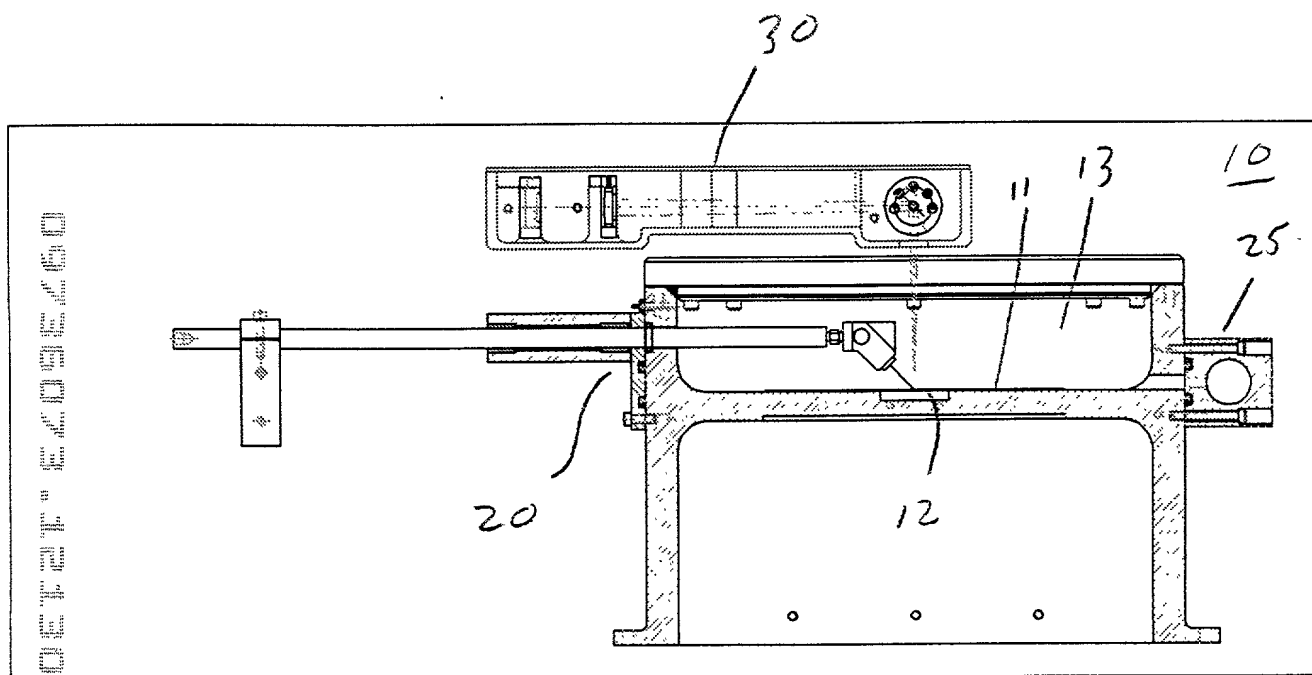


FIG. 4

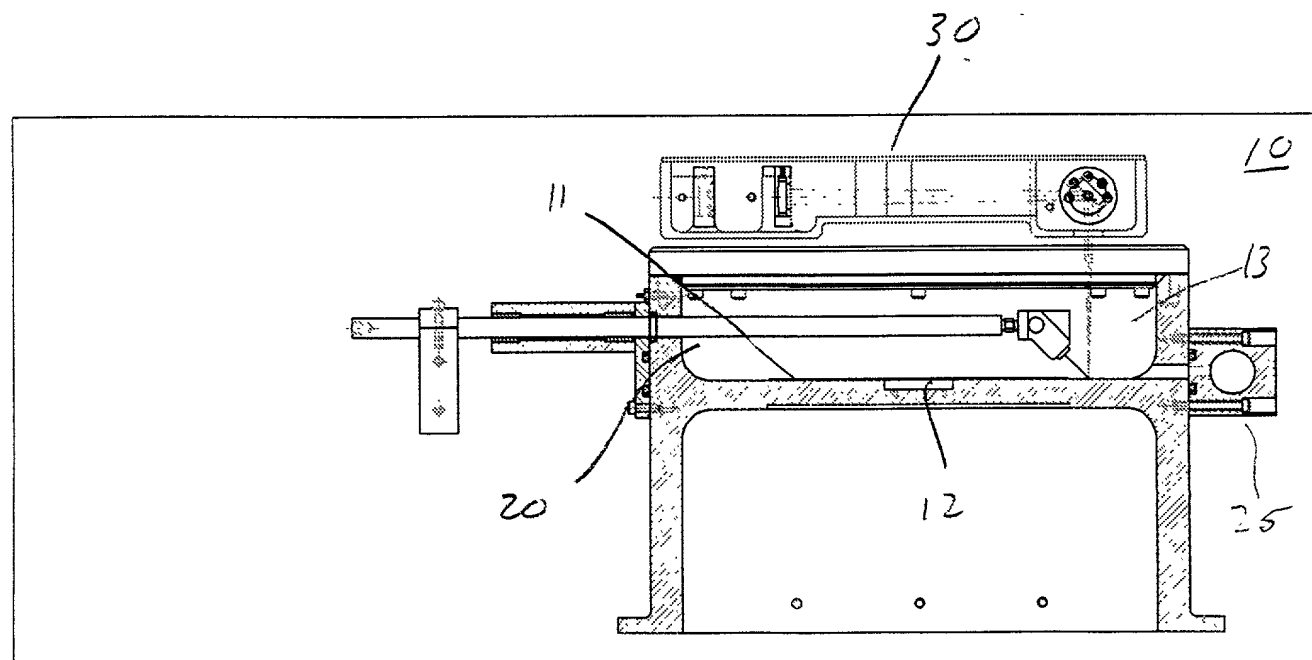
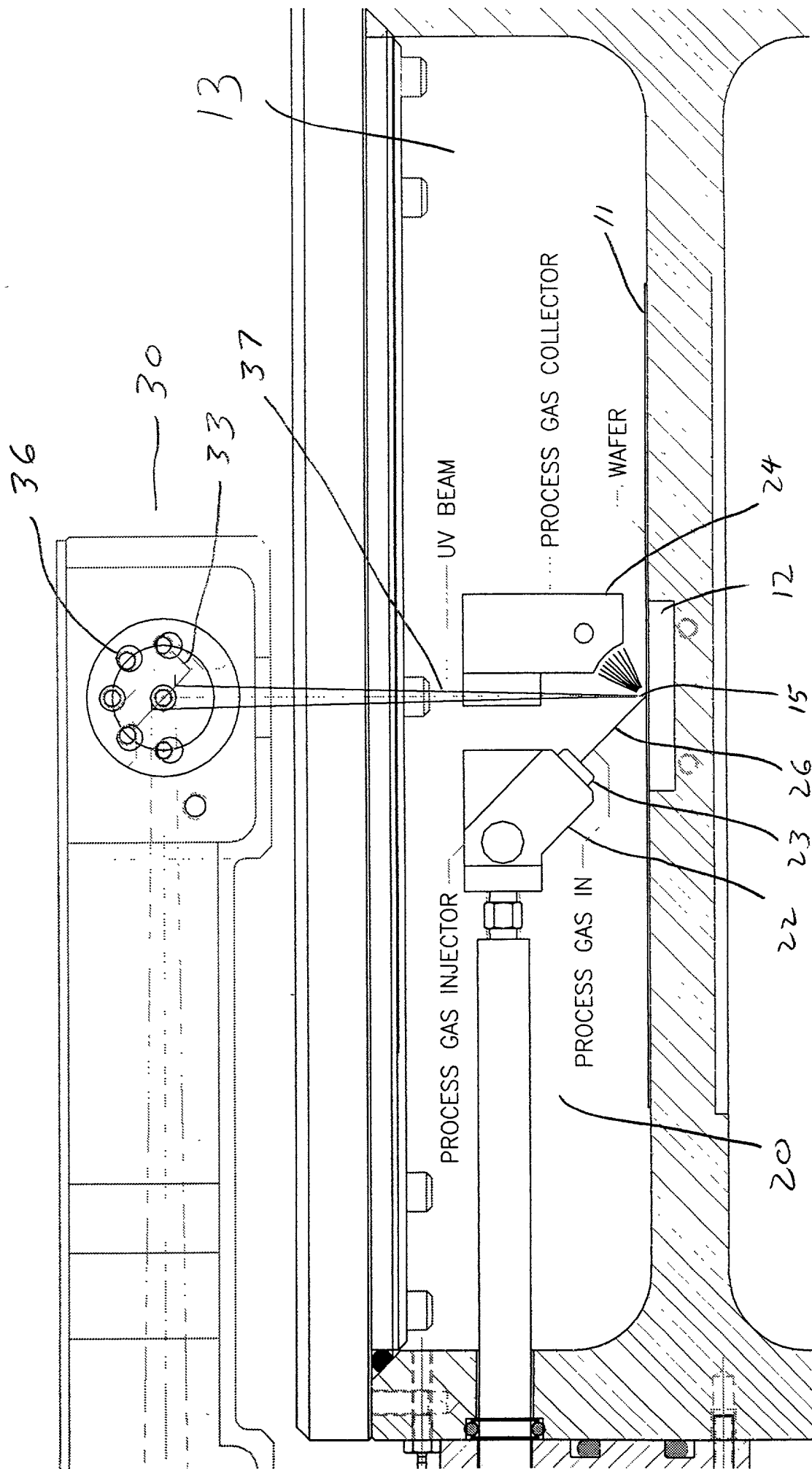
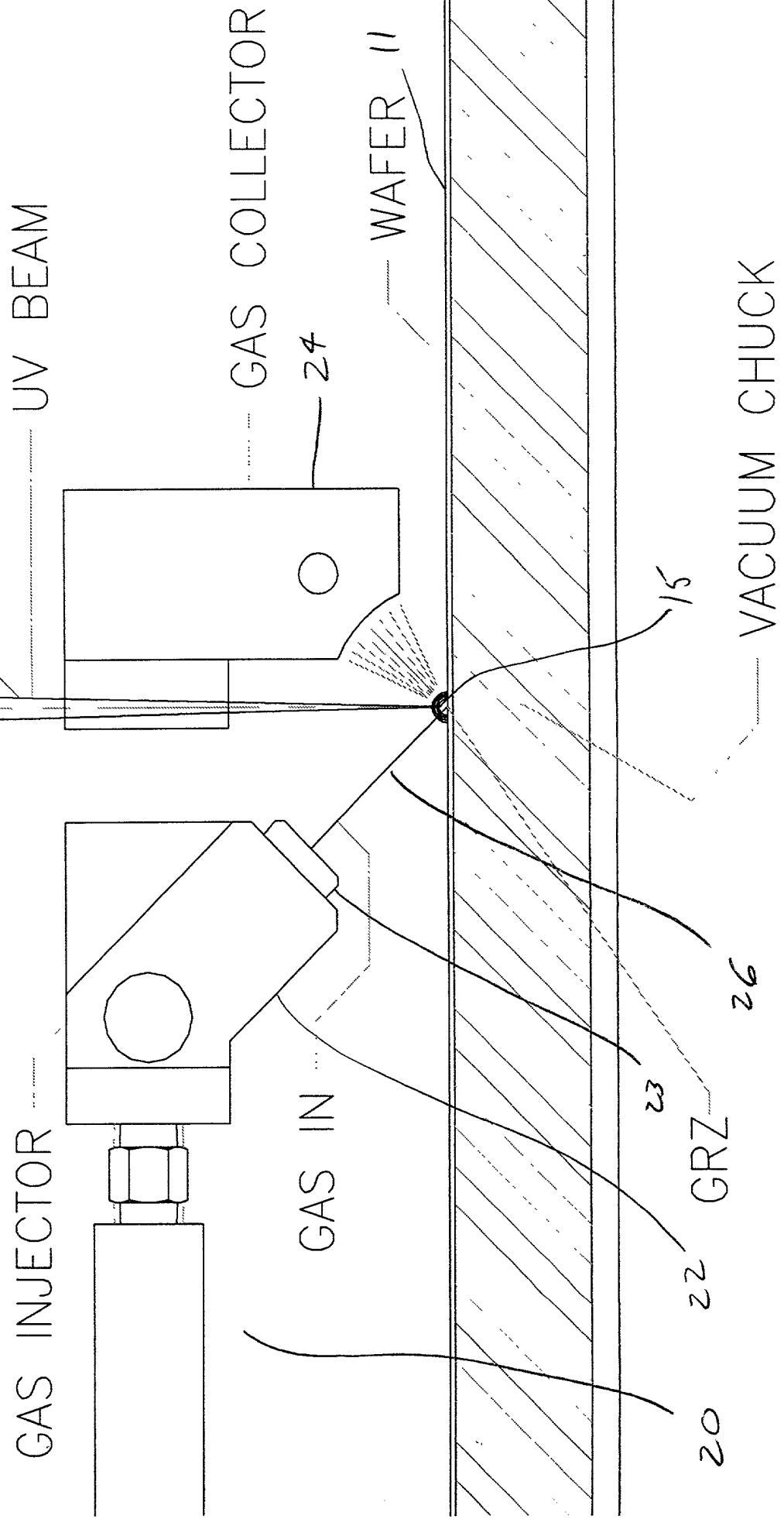
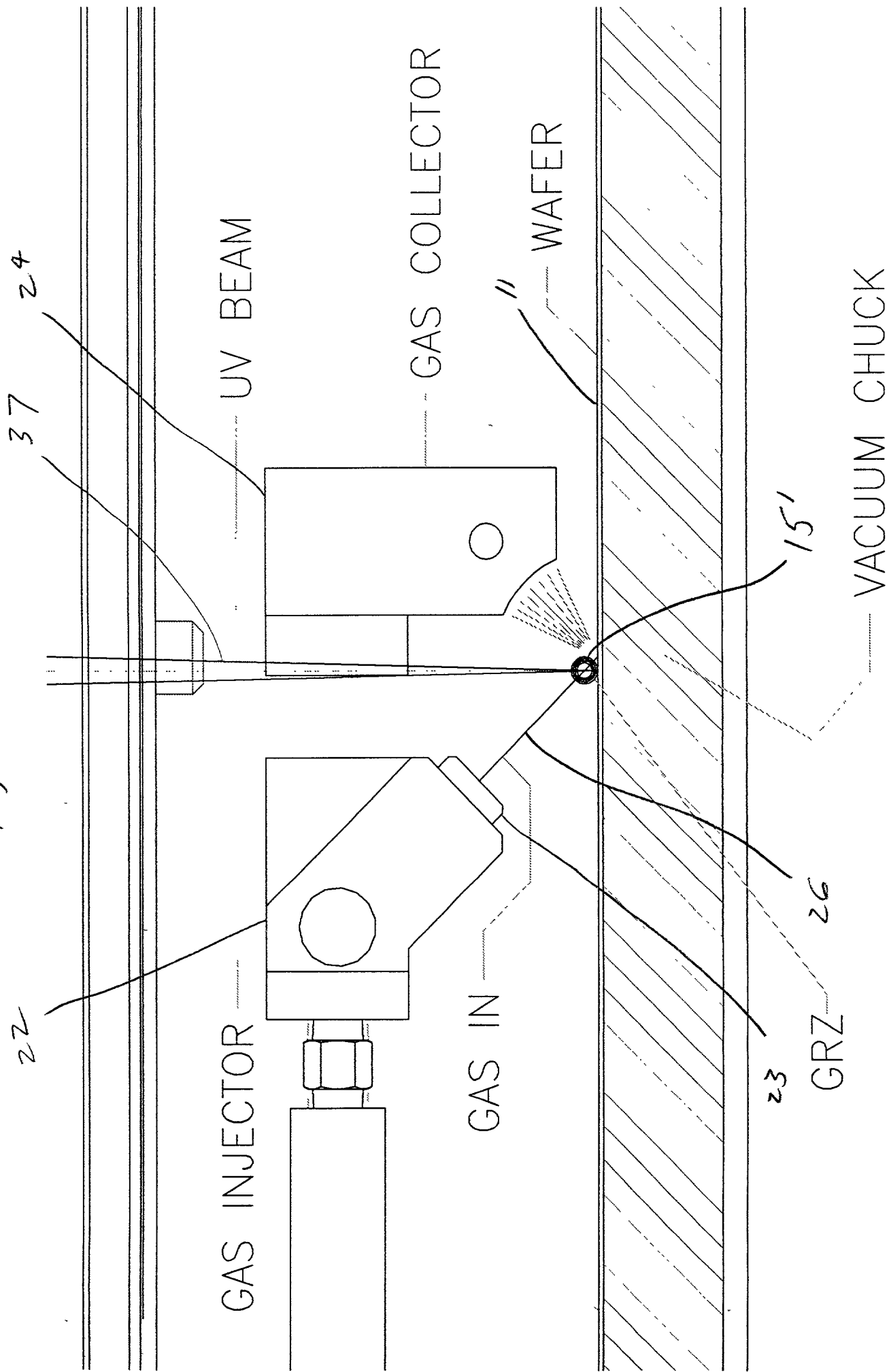


FIG. 5

Fig 6









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Fig. 10

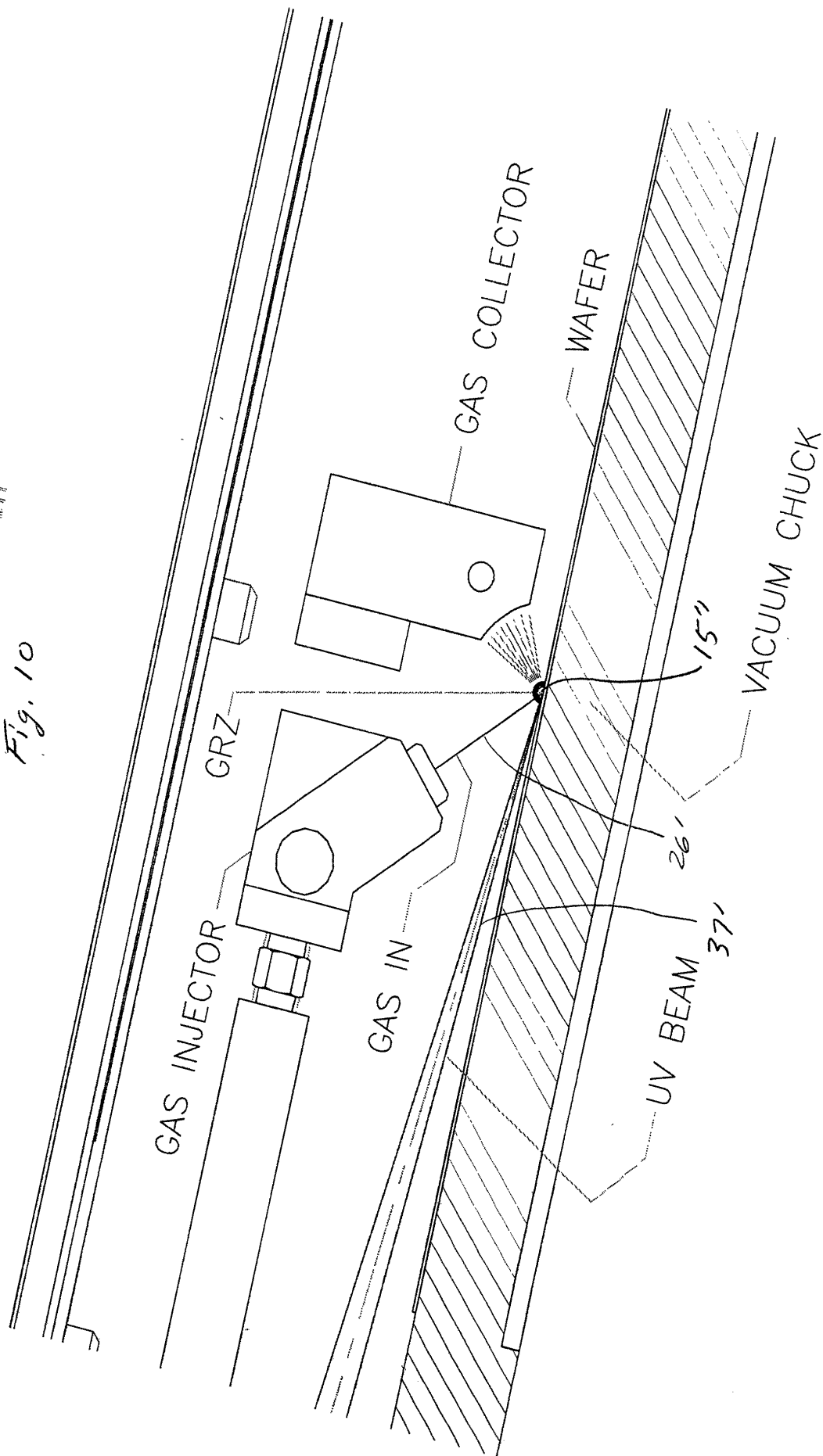




Fig. 11

